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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Calvin T. Gabriel et al.

Title: PROCESS FOR IMPROVING  
THE ETCH STABILITY OF  
ULTRA-THIN PHOTORESIST

Appl. No.: 09/819,552

Filing Date: 3/28/2001

Examiner: Binh X. Tran

Art Unit: 1765

<b>CERTIFICATE OF FACSIMILE TRANSMISSION</b> I hereby certify that this paper is being facsimile transmitted to the United States Patent and Trademark Office, Alexandria, Virginia on the date below.  Kathryn I. Berg (Printed Name)  Kathryn I. Berg (Signature)  July 6, 2004 (Date of Deposit)
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AMENDMENT AND REPLY UNDER 37 CFR 1.116

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

This communication is responsive to the Final Office Action dated May 4, 2004,  
concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2  
of this document.

Remarks/Arguments begin on page 6 of this document.

Please amend the application as follows:

001.1652243.1

Application No. 09/819,552